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Author: An Pan Jinhai Si Tao Chen Cunxia Li Xun Hou

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Fabrication of two-dimensional periodic structures on silicon after scanning irradiation with femtosecond laser multi-beams

An Pana, Jinhai Sia*, Tao Chena, Cunxia Lib and Xun Houa

^aKey Laboratory for Physical Electronics and Devices of the Ministry of Education and

Shaanxi Key Lab of Information Photonic Technique, School of Electronics and Information

Engineering, Xi'an Jiaotong University, Xi'an 710049, China

^bDepartment of Applied Physics, Xi'an University of Technology, Yanxiang Road 58, Xi'an,

710054, China

Abstract: Two-dimensional (2D) periodic structures were fabricated on silicon surfaces by

femtosecond laser irradiation in air and water, with the assistance of a microlens array (MLA)

placed in the beam's path. By scanning the laser beam along the silicon surface, multiple

grooves were simultaneously fabricated in parallel along with smaller laser-induced ripples.

The 2D periodic structures contained long-periodic grooves and perpendicular short-periodic

laser-induced ripples, which had periods of several microns and several hundred nanometers,

respectively. We investigated the influence of laser power and scanning velocity on the

morphological evolution of the 2D periodic structures in air and water. Large-area grid-like

structures with ripples were fabricated by successively scanning once along each direction of

the silicon's surface, which showed enhanced optical absorption. Hydrofluoric acid was then

used to remove any oxygen and laser-induced defects for all-silicon structures.

Keywords: Femtosecond laser; silicon; periodic structures; combined structures.

*Corresponding author. E-mail address: jinhaisi@mail.xjtu.edu.cn; Tel: +86 029 82663485.

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